

Notice of References Cited	Application/Control No. 10/541,384	Applicant(s)/Patent Under Reexamination TAKEI ET AL.	
	Examiner Nam Huynh	Art Unit 2617	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0186724	10-2003	Tsutsumi et al.	455/561
*	B	US-6,990,583	01-2006	Matsuyama et al.	713/175
*	C	US-6,925,094	08-2005	Sharony et al.	370/468
*	D	US-2003/0119562	06-2003	Kokubo, Takeshi	455/566
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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